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BIBDATASHEET

CONFIRMATION NO. 1066

Bib Data Sheet

SERIAL NUMBER 10/602,644	FILING DATE 06/25/2003 RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. 520.37386VC2
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** CONTINUING DATA *****

This application is a DIV of 10/026,615 12/27/2001 PAT 6,635,913
 which is a CON of 09/341,523 08/13/1999 PAT 6,342,712,

which is a 371 of PCT/JP98/00027 08/01/1998.

** FOREIGN APPLICATIONS *****

JAPAN 9-003571 01/13/1997

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 09/10/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials	JAPAN	21	4	1

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TITLE

SEMICONDUCTOR STORAGE DEVICE MANUFACTURING METHOD WHICH FORMS A HYDROGEN DIFFUSION INHIBITING LAYER

☐ All Fees☐ 1.16 Fees (Filing)

FILING FEE

FEES: Authority has been given in Paper